## **Accepted Manuscript**

Motivation to Learn in Massive Open Online Courses: Examining Aspects of Language and Social Engagement

Miri Barak, Asst. Prof., Abeer Watted, Mrs., Hossam Haick, Prof.

PII: \$0360-1315(15)30082-8

DOI: 10.1016/j.compedu.2015.11.010

Reference: CAE 2948

To appear in: Computers & Education

Received Date: 11 May 2015

Revised Date: 9 November 2015 Accepted Date: 21 November 2015

Please cite this article as: Barak M., Watted A., & Haick H., Motivation to Learn in Massive Open Online Courses: Examining Aspects of Language and Social Engagement, *Computers & Education* (2015), doi: 10.1016/j.compedu.2015.11.010.

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#### ACCEPTED MANUSCRIPT

#### Title page

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Asst. Prof. Miri Barak,

Head of the Science and Learning Technology Group

The Department of Education in Science and Technology,

Technion-Israel Institute of Technology, Haifa 320003, Israel.

Email: bmiriam@technion.ac.il

Tel: 972-4-8293883 Fax: 972-4-8295634

#### Mrs. Abeer Watted

The Department of Education in Science and Technology,

Technion-Israel Institute of Technology, Haifa 320003, Israel.

Email: abeerw@tx.technion.ac.il

#### Prof. Hossam Haick

The Department of Chemical Engineering

Technion-Israel Institute of Technology, Haifa 320003, Israel.

Email: hhossam@tx.technion.ac.il

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